

Article

Selective Laser Sintering of Laser Printed Ag Nanoparticle Micropatterns at High Repetition Rates

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Below two supplementary Figures S1 and S2, can be found.

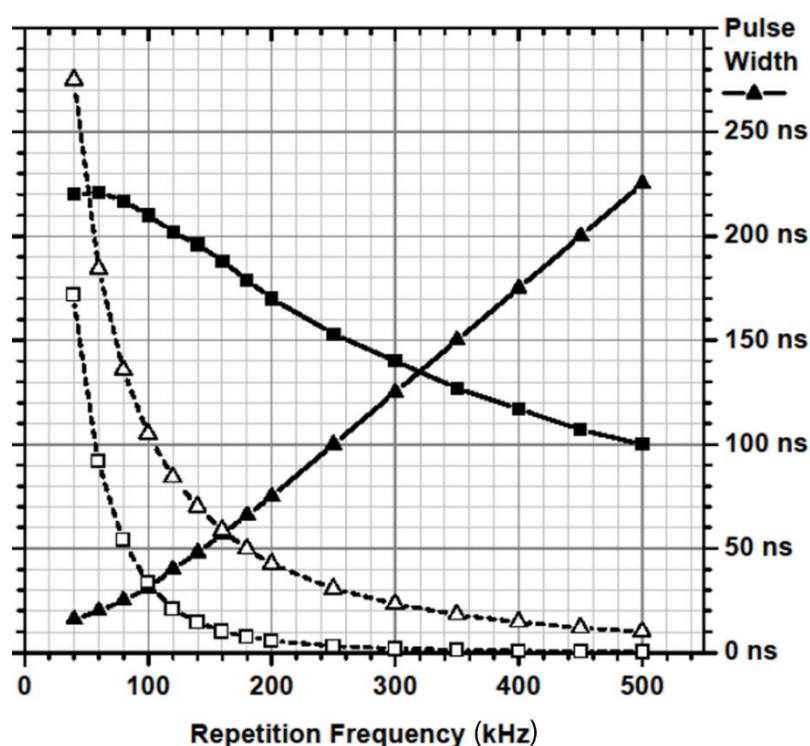


Figure S1. Performance of the high repetition rate laser utilized in this study according to the manufacturer. Pulse width increases for increasing Repetition Frequency.

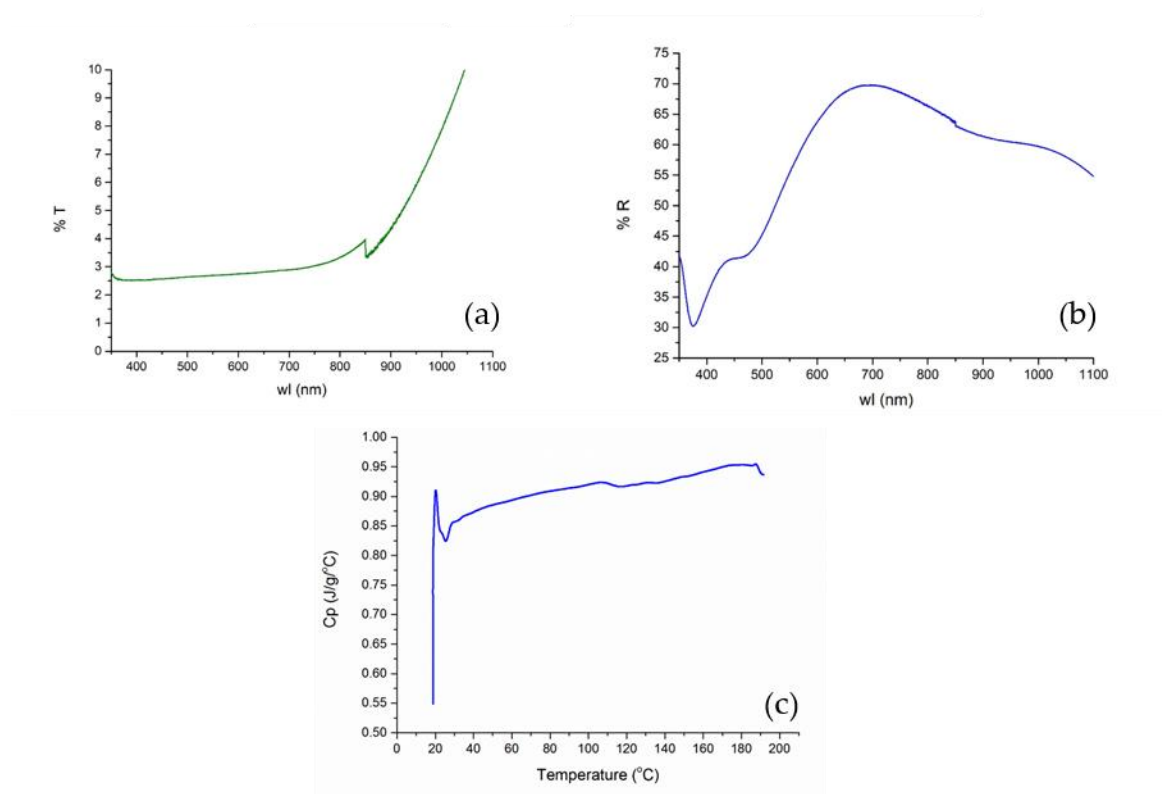


Figure S2. Measured T (a); R (b) spectra for 180 nm thick spin coated Ag nanoparticle ink for the 350–1100nm range and (c) Cp vs T for the same ink.



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